



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vishwanathan et al.

Application No.: 09/608,537

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Title: POLISHING PADS FOR CHEMICAL
MECHANICAL PLANARIZATION

Attorney Docket No.: 126

Commissioner for Patents
Alexandria, VA 22313-1450

Group Art Unit:
3724

Examiner:
T. Eley

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TECHNICAL STAFF

PRELIMINARY AMENDMENT

Dear Sir:

Before examination of this patent application, kindly amend the specification as follows: